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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP03/10934 08/28/2003 *MA*

** FOREIGN APPLICATIONS *****

JAPAN 2002-252608 08/30/2002 *MA*

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|--|---|----------------------------|--------------------------|--------------------------------|
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY KOREA, REPUBLIC OF | SHEETS DRAWING 6 | TOTAL CLAIMS 4 | INDEPENDENT CLAIMS 1 |
| 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after | | | | |
| Verified and Acknowledged <i>M. Ahmad</i> Examiner's Signature | <i>MA</i> Initials | | | |

ADDRESS

00909

TITLE

Method of eliminating boron contamination in annealed wafer

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| FILING FEE RECEIVED 1030 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit |
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